504899889 05/04/2018

# PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1 Stylesheet Version v1.2 EPAS ID: PAT4946633

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

#### **CONVEYING PARTY DATA**

Name	Execution Date
FEI ZHOU	04/27/2018

### **RECEIVING PARTY DATA**

Name:	SEMICONDUCTOR MANUFACTURING INTERNATIONAL (SHANGHAI) CORPORATION
Street Address:	18 ZHANGJIANG ROAD, PUDONG NEW AREA
City:	SHANGHAI
State/Country:	CHINA
Postal Code:	201203
Name:	SEMICONDUCTOR MANUFACTURING INTERNATIONAL (BEIJING) CORPORATION
Street Address:	NO. 18, WEN CHANG RD., ECONOMIC-TECHNOLOGICAL DEVELOPMENT AREA, DAXING DISTRICT
City:	BEIJING
State/Country:	CHINA
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## **PROPERTY NUMBERS Total: 1**

Property Type	Number
Application Number:	15971002

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NAME OF SUBMITTER:	LUCILLA FAN
SIGNATURE:	/Lucilla Fan/

PATENT 504899889 REEL: 046079 FRAME: 0993

DATE SIGNED: 05/04/2018

Total Attachments: 2
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PATENT REEL: 046079 FRAME: 0994

# ASSIGNMENT AND DECLARATION

WHEREAS I/We, the below named inventor(s) (hereinafter referred to as Assignor(s)) have made an invention entitled:
SEMICONDUCTOR DEVICES AND FABRICATION METHODS THEREOF
for which I/We executed an application for United States Letters Patent concurrently herewith or filed an application for United States Letters Patent on(Application No); and
WHEREAS, Semiconductor Manufacturing International (Shanghai) Corporation, a corporation of P.R. China whose post office address is 18 Zhangjiang Road, Pudong New Area, Shanghai, China 201293, and Semiconductor Manufacturing International (Beijing) Corporation, a corporation of P.R. China whose post office address is No. 18. Wen Chang Rd. Economic-Technological Development Area Daxing District, Beijing, China 100716 (hereinafter referred to as Assignee), is desirous of securing the entire right, title, and interest in and to this invention in all countries throughout the world, and in and to the application for United States Letters Patent on this invention and the Letters Patent to be issued upon this application:
NOW THEREFORE, be it known that, for good and valuable consideration the receipt of which from Assignee is hereby acknowledged, I/We, as Assignor(s), have sold, assigned, transferred, and set over, and do hereby sell, assign, transfer, and set over unto the Assignee, its lawful successors and assigns, my/our entire right, title, and interest in and to this invention, provisional Application No.
filed
AND, IWE HEREBY covenant that I/We have the full right to convey the interest assigned by this Assignment, and I/We have not executed and will not execute any agreement in conflict with this Assignment.
AND, I/WE HEREBY further coveriant and agree that I/We will, without further consideration, communicate with Assignee, its successors and assigns, any facts known to me/us respecting this invention, and testify in any legal proceeding, sign all lawful papers when called upon to do so, execute and deliver any and all papers that may be necessary or desirable to perfect the title to this invention in said Assignee, its successors or assigns, execute all divisional, continuation, and reissue applications, make all rightful oaths and generally do everything possible to aid Assignee, its successors and assigns to obtain and enforce proper patent protection for this invention in the United States and any foreign country, it being understood that any expense incident to the execution of such papers shall be borne by the Assignee, its successors and assigns.
AND, I/WE HEREBY authorize and request the attorneys I/we have empowered in the Declaration and Power of Attorney in this application, to insert here in parentheses (Application No

**RECORDED: 05/04/2018** 

This declaration is directed to the application attached hereto or United States application or PCT
international application number filed on filed on filed application is not attached hereto, the application is as identified above or by the attorney docket number as sel forth above and/or the following
The above-identified application was made or authorized to be made by me.
I believe that I am the original inventor or an original joint inventor of a claimed invention in the application.
I have reviewed and understand the contents of the above-identified application, including the claims.
I acknowledge the duty to disclose information which is material to patentability as defined in Title 37.Code of Federal Regulations § 1.56, including for continuation-in-part applications, material information which became available between the filing data of the prior application and the national or PCT International filing date of the continuation-in-part application.
I hereby acknowledge that any willful false statement made in this declaration is punishable under 18 U.S.C. §1001 by fine or imprisonment of not more than five (5) years, or both.
IN TESTIMONY WHEREOF, I/We have hereunto set our hands.
Inventor 1 Fei ZHOU
Legal Name: